

Monday									
Room No.	Capacity	I	II	III	IV	V	VI	VII	VIII
CR1	30		EE 204	EE 205		CS 306	CS 305	EE 701	
CR2	30		EE 305	CS 304			EE 306	EC 413	
CR3	30	CS 205	CS 208	CE 519	EE 423		EE 411		
CR4	30		CS 510	CS 516		CE 332	CE 508		
CR5	75		CY 102	MA 102			CS 204	EC 306/ CS 313	
CR6	25	EC 205		ME 206					
CR7	30	CE 209	EC 305	CE 325	ME 327	CE 207	ME 206	CE 329	ME 327-T
CR8	60	EC 307	ME 325	ME 326/ ME 510			ME 325	ME 304	AD 701
CR9	30		CE 306	EC 416		ME 205	CE 206	ME 208	CE 305
CR10	60	HS 301	MA 203			MA 203	EC 526	ME 506	
CR11	40		EE 504	EE 512	EE 510	CE 504	EC 304		CH 539
CR12	20	PH 406	PH 405	PH 407	PH 408		EE 520	CH 701	
CR13	20		CE 512	EC 502	CS 504		CE 519		
CR14	20	CS 502		CS 519	MA 536		MA 531		
CR15	20		CS 515	PH 504		PH 554	PH 542		
CR16	20	CH 405	CH 406	CH 408			CH 406	MA 702	
CR17	25		CH 534	CH 504		CH 538			
CR18	30		MA 408	MA 410	MA 411		MA 407		
CR 19	25		CE 432	CE 433					
LH	90		MA 102				EE 101	CS 101	PH 101
Lang Lab				CS 256 Lab					
Eng. Draw. Room									
BEE Lab									
PH Lab				PH 151					
CH Lab							CH 482		
Computer Center		CS 356		CS 151				MA 210 L	
Computing Lab							CS 258 L		
Thermal Engineering Lab									
Fluid Mechanics Lab									
COMPUTER LAB									
Basic Electronincs Lab				EE 151				EC 254 L	
Digital System Design Lab		EC 558 L/EC518 L		EC 356 L					
Comm. Systems Lab									
Microwave Lab									
Microprocessor Lab									
Power System Lab									
Power Electronics Lab									
Machine Lab									
Control and instrumentation lab									
ME and CE Computational Lab									
Advanced Manufacturing Lab									
ME Workshop						ME 102 (CE)			
New CC								CS XXX Data Mining Lab	

Tuesday										
Room No.	Capacity	I	II	III	IV	V	VI	VII	VIII	IX
CR1	30	EE 205	EC 526	EE 206	EC 413		EE 204		EE 701	
CR2	30	EC 304	EE 306	EE 321	EE 304		EE 312			
CR3	30	EC 504	EC 307	EE 411	EE 423		EE 415			
CR4	30	CS 208	CS 206	ME 321	ME 321		CS 207			
CR5	75		CY 101	MA 102	EC 306/ CS 313		EC 316			
CR6	25	EC 204	EC 205	EC 205			EC 204			
CR7	30	CE 206				CE 207	CE 209	ME 207		
CR8	60	ME 205	HS 301	CE 325	CE 329	EC 413	ME 325+ME 504	ME 427+ME 512		
CR9	30	CE 305	CS 519	CS 306	CS 313	ME 206	CS 315	CE 208		
CR10	60	ME 305	CS 211	MA 203		MA 203	EC518			
CR11	40		CS 522	CH 539		CE 504				
CR12	20	PH 406	PH 407	PH 405	PH 409		PH 408			
CR13	20	ME 701	EE 504	EC 502	EE 520		EE 502			
CR14	20	ME 502	MA 531		CS 504		MA 536			
CR15	20		CE 502		PH 504					
CR16	20	CH 407	CH 406	CH 405						
CR17	25		CH 504	ME 437		CH 534	CH 538			
CR18	30	MA 410	MA 409	MA 408	MA 411		EC 312			
CR 19	25	CE 431	CE 432	CE 433			CE 307		CE 305	
LH	90	CY 102	EE 101	PH 101			EE 210	MA 102	CS 101	
Lang Lab								ME 327 Lab.		
Eng. Draw. Room										
BEE Lab										
PH Lab						PH 151 (EE)				
CH Lab							CH 482			
Computer Center		CH 539 (CSE+CY)				CS 151 (CS)		CS 255 Lab		
Computing Lab		CS 355 Lab						CS 354 Lab		
Thermal Engineering Lab			ME 552							
Material Science Lab										
Fluid Mechanics Lab										
COMPUTER LAB										
Basic Electronics Lab										
Digital System Design Lab								EC 552 L		
Comm. Systems Lab										
Microwave Lab								EC 357 L		
Microprocessor Lab								EE 562		
Network Lab										
Power System Lab										
Power Electronics Lab										
Machine Lab										
Control and instrumentation lab								EE 560		
ME & CE Computational Lab									CE 552	
ME Workshop							ME 102 (ME)			
New CC								CS 261 Lab		

Wednesday									
Room No.	Capacity	I	II	III	IV	V	VI	VII	VIII
CR1	30				CS 315			EE 205	EE 206
CR2	30				EE 304	EC 504	EC 526	EE 701	EE 306
CR3	30					EC 305		EE 415	
CR4	30				CS 207		CS 205	CS 515	CS 515
CR5	75					EC 101			CS 101
CR6	25			ME 506					EC 312
CR7	30				CE 306		CE 208	CE 305	CE 332
CR8	60						ME 325+ME 504		EC 316
CR9	30				ME 305		CE 307	ME 437	ME 433
CR10	60				ME 701		CE 431		AD 701
CR11	40							CS 516	CS 516
CR12	20				PH 405			EC 506	
CR13	20				EE 502		EE 510	CH 701	
CR14	20				CS 504		EE 512	CE 502	
CR15	20				PH 542		PH 554	MA 702	
CR16	20				MA 531	CH 407	CH 406	CH 408	MA 702
CR17	25								
CR18	30				MA 409		MA 407	MA 410	MA 408
CR 19	25				CE 433			CE 432	
LH	90					EE 210	HS 302		
Lang Lab									
Eng. Draw. Room									
BEE Lab						EE 151 (EE)			
PH Lab									
CH Lab							CY 151 (ME)		
Computing Center						MA 210 L		CS 254 Lab	
Computing Lab									
Fluid Mechanics Lab							ME 213 (Fluid Machine Lab.)		
ME Workshop									
Theory of Machine Lab							ME 213 (Theory of Machines Lab.)		
COMPUTER LAB									
Basic Electronincs Lab							EC 151 (CE)		
Digital System Design Lab									
Comm. Systems Lab									
Microwave Lab									
Microprocessor Lab									
Network Lab									
Power System Lab									
Power Electronics Lab									
Machine Lab									
Control and instrumentation lab									
ME & CE Computational Lab						CE 556		CE 562	
TOM Lab									
Advanced Manufacturing Lab		ME 313 (Advanced Manufacturing Lab.)							
Metrology and Instrumetnation Lab		ME 313 (Metrology and Instrumentation Lab.)							
ME Workshop							ME 102 (CS)		

Thursday										
Room No.	Capacity	I	II	III	IV	V	VI	VII	VIII	IX
CR1	30	EC 316	EE 204	EE 206			EC 701	EC 204		
CR2	30	EE 306	EE 305	EE 304	EE 321			EE 312		
CR3	30	CS 305	CS 304	EE 423	EE 411		EE 415	ME 304		
CR4	30	CS 208	CS 206	CH 539	CS 207		EC 413			
CR5	75	CS 211	CS 101	EC 101		CY 101	CY 102	MA 102	CS 205	
CR6	25	EC 312	EC 305	EC 307	EC 304					
CR7	30	EC 416	CE 206	CS 306	CS 315	CE 206	CE 208	CE 207	CE 209	
CR8	60	MA 203	ME 326	MA 203			CE 506			
CR9	30	ME 207	ME 208	CS 519		CE 329	CE 305			
CR10	60	HS 301	ME 437	ME 433	ME 427+ME 512	ME 208			AD 701	
CR11	40	CE 502	CE 504	CE 512	EC 518					
CR12	20	PH 406	PH 407	PH 405	PH 409		PH 408			
CR13	20	EE 510	EE 512		CS 504	CE 519	EE 502	EE 520		
CR14	20		ME 502		MA 536	ME 701				
CR15	20			PH 542						
CR16	20		CH 407	CH 408	MA 702	CH 405				
CR17	25		CH 504	CE 307		CH 538				
CR18	30	MA 409	MA 411	CS 522	MA 407					
CR 19	25		CE 432	CE 431						
LH	90	CY 102	MA 102	PH 101	EE 210		HS 302	EC 306		
Lang Lab			ME 326 Lab							
Eng. Draw. Room										
BEE Lab						EE 151 (EC)				
PH Lab						PH 151 (CS)				
CH Lab							CH 482			
Computer Center						MA 210 L				
Computing Lab			EC 255 L							
Fluid Mechanics Lab							ME 213 (Fluid Machine Lab.)			
TOM Lab							ME 213 (Theory of Machines Lab.)			
COMPUTER LAB										
Basic Electronics Lab										
Digital System Design Lab		EC 560 L								
Comm. Systems Lab			EC 255 L							
Microwave Lab										
Thermal Engineering Lab										
Microprocessor Lab										
Power System Lab										
Power Electronics Lab										
Machine Lab										
Control and instrumentation lab										
ME & CE Computational Lab			ME 325 Lab.				ME 556 Lab.			
ME Workshop							ME 102 (EE)			

Friday									
Room No.	Capacity	I	II	III	IV	V	VI	VII	VIII
CR1	30	EE 206	CS 304	EE 205	EC 701	EE 204			
CR2	30		EE 312	EE 304	EE 321		EE 305	CY 5XX	
CR3	30	CS 313	EE 411	CS 305					
CR4	30	CE 209		EC 305	EC 416	CS 205	CS 206		
CR5	75	CS 204		MA 102		CY 101	CS 101		CS 211
CR6	25								
CR7	30	ME 208		EC 205		EC 205	EC 204		
CR8	60		MA 203	CE 508					
CR9	30	CE 329	CE 306	ME 207		CE 325	CE 332		
CR10	60		ME 205				ME 437		AD 701
CR11	40		CH 539	EC 518					
CR12	20	PH 406	PH 408	PH 407	PH 409		CS 504	CH 701	
CR13	20	CE 512	CE 519						
CR14	20	EC 502	EC 504	EE 504			MA 531		
CR15	20			PH 504	PH 554				
CR16	20			CH 408	CH 406		CH 407	CH 405	
CR17	25					CH 534			
CR18	30	MA 409	MA 411	MA 410	MA 408		MA 407		
CR 19	25					CE 431			
LH	90	PH 101	MA 102	CS 101					
Lang Lab									
Eng. Draw. Room									
BEE Lab									
PH Lab									
CH Lab			CY 151 (CE)						
Computer Center			CS 151 (ME)			MA 210 L		CS 151 (CE)	
Thermal Engineering Lab									
Material Science Lab									
Computing Lab	EC 463 L							EC 354 L	
Fluid Mechanics Lab									
COMPUTER LAB									
Basic Electronics Lab								EC 151 (ME)	
Digital System Design Lab		EC 355 L					CS 313 Lab		
Comm. Systems Lab									
Microwave Lab									
Microprocessor Lab									
Networks Lab									
Power System Lab									
Power Electronics Lab									
Machine Lab									
Control and instrumentation lab									
Advanced Manufacturing Lab						ME 313 (Advanced Manufacturing Lab.)			
Metrology and Instrumentation Lab						ME 313 (Metrology and Instrumentation Lab.)			
ME Workshop							ME 102 (EC)		
New CC			CH 539 Lab						